

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazuki HONMA et al.

Appln. No.:

Filed: Herewith

For: SEMICONDUCTOR DEVICE AND METHOD OF THE  
SEMICONDUCTOR DEVICE

\* \* \*

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

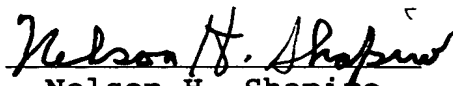
Sir:

Applicants wish to make of record the documents cited in prior Application No. 10/132,248 filed April 26, 2002, whether cited by Applicants or by the Patent Office. The documents are listed on the attached Form PTO-1449.

Respectfully submitted,

NHS:sjk

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